

## Refine Search

### Search Results -

Terms	Documents
L5 and simulation	311

Database:

US Pre-Grant Publication Full-Text Database  
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Search:

L6





### Search History

DATE: Thursday, April 07, 2005    [Printable Copy](#)    [Create Case](#)

<u>Set Name</u>	<u>Query</u>	<u>Hit Count</u>	<u>Set Name</u> result set
<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=NO; OP=OR</i>			
<u>L6</u>	L5 and simulation	311	<u>L6</u>
<u>L5</u>	display\$3 and ((batch ot lot) adj process\$3) and (analysis or analy\$4) and (3d or (three adj dimensional))	931	<u>L5</u>
<u>L4</u>	display\$3 and ((batch ot lot) adj process\$3) and (analysis or analy\$4) and (3d or (three adj dimensional)) and (control\$4 adj region)	3	<u>L4</u>
<u>L3</u>	display\$3 and ((batch ot lot) adj process adj data) and (analysis or analy\$4) and (3d or (three adj dimensional)) and (control\$4 adj region)	0	<u>L3</u>
<i>DB=USPT; PLUR=NO; OP=OR</i>			
<u>L2</u>	L1 and wafer	40	<u>L2</u>
<u>L1</u>	kotani.inv.	650	<u>L1</u>

END OF SEARCH HISTORY